



Sheet 1 of 1

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INFORMATION DISCLOSURE STATEMENT  
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(Use several sheets if necessary)

Applicant: Leonard Forbes et al.

Filing Date: August 14, 1998

Group: 2818

Viet Q. Nguyen  
Primary Examiner

## U.S. PATENT DOCUMENTS

**Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
WN	4,462,150	07/31/1984	Nishimura, H., et al.	29	576 B	09/16/82
WN	4,768,072	08/30/1988	Seki, Y., et al.	357	29	10/02/86
WN	4,841,349	06/20/1989	Nakano, M.	357	30	10/28/87
WN	5,407,845	04/18/1995	Nasu, Y., et al.	438	440	10/13/93
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WN	6,018,166	01/25/2000	Lin, K., et al.	257	22	07/30/98
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WN	6,075,259	06/13/2000	Baliga, B.J.	257	77	07/13/99

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## FOREIGN PATENT DOCUMENTS

**Examiner Initial	Document Number	Date	Country	Class	Subclass	Translation Yes   No
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## OTHER DOCUMENTS

(Including Author, Title, Date, Pertinent Pages, Etc.)

**Examiner Initial	
WN	Zirinsky, S., et al., "Electrical Resistivity of Amorphous Silicon Resistor Films", <u>Extended Abstracts of the Spring Meeting of the Electrochemical Society</u> , Washington, DC, pp. 147-149, (May 1971)

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12/31/00

\*Substitute Disclosure Statement Form (PTO-1449)

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